

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q90606

Akira KOBAYASHI, et al.

Appln. No.: 10/550,897

Group Art Unit: 2812

Confirmation No.: 1704

Examiner: Kevin M. PICARDAT

Filed: September 27, 2005

For: CHEMICAL VAPOR DEPOSITED FILM BASED ON A PLASMA CVD METHOD
AND MEHTOD OF FORMING THE FILM

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

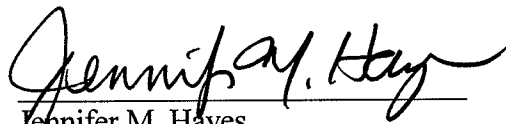
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two months, extending the time for responding to the Office Action of January 14, 2008 from April 14, 2008 to June 16, 2008 (June 14, 2008 being a Saturday).

The statutory fee of \$460.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,


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WASHINGTON OFFICE

23373

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Date: June 16, 2008